

Notice of References Cited	Application/Control No. 10/559,840		Applicant(s)/Patent Under Reexamination DEL PRADO PAVON ET AL.	
	Examiner BEN H. LIU		Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0210673 A1	11-2003	Nishimura, Takuya	370/338
*	B	US-7,031,338 B2	04-2006	Weaver, Jeffrey S.	370/465
*	C	US-7,310,353 B1	12-2007	Bourlas et al.	370/473
*	D	US-7,317,735 B1	01-2008	Ojard, Eric J.	370/470
*	E	US-7,346,026 B2	03-2008	Sherman et al.	370/328
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
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	X				

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